

31040 U.S. PTO
10/056341
01/28/02

1145

U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM 10058341	FILING DATE 01/28/2002	CLASS 204	SUBCLASS 102.12	GAU 1753 1741	EXAMINER VerSteeg
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**APPLICANTS: Yamamoto Tatsushi; Tadera Takamitsu;

**CONTINUING DATA VERIFIED: SHV

NOR

** FOREIGN APPLICATIONS VERIFIED: SHV

JAPAN P2001-20532 01/29/2001

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no			ATTORNEY DOCKET NO 70868/56922
35 USC 119 conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no			
Verified and Acknowledged Examiners's initials SHV			
TITLE : Backing plate used for sputtering apparatus and sputtering method			

U.S. DEPT. OF COMM./PAT. & TM.-PTO-435L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Assistant Examiner	Total Claims
			Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Primary Examiner	Sheets Drawg. Figs. Drawg. Print Fig.
<input type="checkbox"/> TERMINAL		PREPARED FOR ISSUE	Application Examiner
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